



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Heon Lee

Docket No.: 10007140-1

Application No. : 10/062,952

Group Art Unit: 1765

Filed: 01/31/2002

Examiner: Powell, William A.

Title: NANO-SIZE IMPRINTING STAMP USING SPACER TECHNIQUE

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AMENDMENT AND RESPONSE UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This amendment is responsive to an Office Action, mailed **28 August 2003**, for the above-identified patent application.

AMENDMENT

Please Amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the **Claims Listing** which begins on **Page 2** of this response.

Remarks and an **Argument** begin on **Pages 6** and **9** respectively of this response.

A **Conclusion** begins on **Page 10** of this response.